Roadmapping Workshop: Measurement Science for Polymer-Based Additive Manufacturing

June 9-10, 2016 ● National Institute of Standards and Technology ● Gaithersburg, MD

Report Out June 10, 2016

Breakout Out Group: Materials Characterization





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Desired AM Capabilities/Technologies

Predictive Capabilities

•Correlation of materials properties with process parameters

•Prediction of material/mechanical properties from starting material characteristics

Properties Databases

- •Compatibility with conventional parts
- •Shelf life of filaments

•High temp polymer chemical/performance data to integrate into design/predictive models

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• PB Materials

•Ability to purchase standardized filament material

•Class of materials to replace injection-molded parts over long term

•How to tailor materials voxel-by-voxel

Materials Processing/Printing

•True 3D printing

•Engineering control to get a range of properties from a single feedstock

•Printing processes/materials with no/less post-processing

•Life Cycle

•Understand cradle to grave impacts of PB AM materials

•Traceability of part, recycle history



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Top-Voted Challenges/Priority Topics

- Standardized Materials create reference materials, material standards for PB AM materials
- •Closed Loop Systems develop materials-machine parameter standards – could be platform for research grade equipment
- •Large (ginormous) Variable Problem understanding and resolving the important key variables, gaining key knowledge, data
 - •Experimental data on part lifetime/aging
 - •Impacts of process/materials parameters on finished part
- •Materials Characterization characterizing shear and other key properties contributing to non-equilibrium
- •Benchmarking Materials from nm to mesoscale, and at interfaces